

Soutenance de thèse

M. Rovezzi

Introduction Spintronics XAFS

Fe in GaN Incorporations Series

Mn in Ge Models NCs results

Mn in GaAs Models Surface study Etch-anneal

Conclusions



# Étude de l'ordre locale autour d'impuretés magnétiques dans les semiconducteurs pour l'électronique de spin

Thèse pour obtenir le grade de Docteur en Sciences de l'Université Joseph Fourier - Grenoble I Spécialité Physique de la Matière Condensée et du Rayonnement

Mauro Rovezzi

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# Study of the local order around magnetic impurities in semiconductors for spintronics

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October 6<sup>th</sup>, 2009



### Outline

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### The whole work:

- I. Fe in GaN
- II. Mn in Ge
- III. Mn in GaAs
- IV. Mn in GaAs/InAs NanoWires

### Additional work:

- A. GIXAS exp. set-up
- B. CARD software
- C. Mn in ZnSe and CdSe

### This talk:

- Introduction
  - Semiconductor spintronics
  - XAFS

### Pe in GaN

- Incorporations
- Series
- Co-doping
- 3 Mn in Ge
  - Models
  - NCs results
- Mn in GaAs
  - Models
  - Surface study
  - Etch-anneal process
- General conclusions and outlook





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## Semiconductor spintronics

Combination of semiconductor technology (charge) with magnetism (spin)

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### Spin-polarized field-effect transistor [Datta & Das, Appl. Phys. Lett. (1990)]

- Efficient spin injection
- Long spin diffusion (nm-µm) and efficient spin manipulation
- Reliable spin detection



### Magnetic semiconductors (MS)

- Electric spin injection better than optical for real devices
- Injection by ferromagnetic metals is inefficient (conductivity mismatch) ⇒ tunnel juctions or ferromagnetic semiconductors
- Advantage in MS: control electric properties using a magnetic field and vice versa their magnetic properties using an electric field
- Need high Curie temperature (T<sub>C</sub>), beyond room temperature



# Diluted Magnetic Semicondutors (DMS)



Semiconductor  $(A_{1-x}B_x)$  where a fraction x of the cations (few %) is randomly substituted by magnetic elements as transition metals (TMs)

### Origin of ferromagnetism $\Rightarrow$ exchange interactions

- TMs introduce localized energy levels (in the band gap for III-V)
- Magnetic order: interplay between spin degree of freedom, Coulomb • interactions and Fermi statistics; not crucial for magnetic order: dipole-dipole and spin-orbit (relativistic effect)
- s(p)-d, and d-d exchage: former direct between band states and TM, latter indirect (mediated by valence/conduction band states)

#### "low"-T<sub>C</sub> FM DMS: electronic nanoscale phase separation

Zener mean field model

 $\mathcal{H} = \mathcal{H}_0 + \sum_{i \in I} J_{pd} S_i \cdot s_i \to T_C \propto J_{pd}^2 x_{eff} p^{1/3}$  increasing p and  $x_{eff}$ !

[Dietl et al., Science (2000)]

- Disorder  $\Rightarrow$  need to consider defects of compensation (E.g. in III-V):
  - Anti-sites affect the density of carriers
  - Interstitials affect also the density of magnetically active TMs



### Non-uniform magnetic semiconductors

gh"-T<sub>C</sub> FM: chemical nanoscale phase separation

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### Spinodal decomposition

#### [Cahn and Hilliard works ('60s)]

- ∂<sup>2</sup>f/∂c<sup>2</sup> < 0 ⇒ decompose spontaneously; phase transition small in degree (composition change) but large in extent (size)
- $\partial^2 f/\partial c^2 > 0 \Rightarrow$  nucleation and growth; phase transition large in degree but small in extent



- TM-rich and TM-poor regions with the structure of the host crystal
- TM-rich region is high T<sub>C</sub> and accounts for magnetization at RT
- Controlled by Fermi level during growth (Coulomb repulsion)

#### Magnetism: ab initio approach

### No semi-phenomenological ${\cal H}$

- DFT + Monte Carlo
- GaMnN: a,c) high-T<sub>C</sub>; b) low-T<sub>C</sub>

# 

[Katayama-Yoshida et al. (2007)]





# XAFS in the study of (D)MS

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- Element-selective (x-ray absorption edges of the elements)
- Local probe (< 10 Å from the absorbing atoms)
- No need long-range order (complementary to XRD)
- $\bullet\,$  Sensitive to impurities (detection limit:  $\approx 10^{14} \text{ at/cm}^2)$
- Accurate bond distances (resolution:  $\approx$  1%)
- Charge state (from near-edge region)

### Disadvantages

- Average signal (difficult to resolve mixed phases if present in small quantities, limit: ≈ 20%)
- No spatial resolution in the sample (bulk probe)





### X-ray Absorption Fine-Structure

Measurements and theory basics

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### Absorption coefficient $\mu(E)$ $\mu(E)t = -ln(I/l_0)$ , transmission

 $\mu(E) \propto I_f/I_0$ , fluorescence

A Neustile, 2004 X-ray Absorption Fine-Structure photo-electron λ-(E-E<sub>0</sub>)<sup>-1/2</sup> XAFS XAFS XAFS XAFS XAFS Absorption Probability



- Absorption through photo-electric effect
- Photo-electron scattering and interference with itself
- Core-hole filled and fluorescent x-ray emitted

- s results in GaAs dels
- Surface study Etch-anneal

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### X-ray Absorption Fine-Structure

Overview of the quantitative analysis



From "scattering paths"  $\rightarrow$  distances, coodination numbers and mean-square disorder around absorber









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General purpose Italian beamLine for Diffraction and Absorption

- Source: bending magnet
- Monochromator: double crystal with sagittal focusing (horizontal)
- Mirrors (for harmonics rejection): Pd/Pt with bending (vertical focusing)
- Energy range: 4 80 KeV
- Energy resolution ( $\Delta E/E$ ): 10<sup>-4</sup>
- Flux on the sample: 10<sup>8</sup> 10<sup>11</sup> ph/s
- Minimum beam-size (vertical): 30  $\mu m$
- Detector for reflectivity and monitoring: ion chambers
- Detector for fluorescence: 13 elements high purity Ge
- Detection modes: transmission, normal fluorescence, total electron yield, grazing-incidence (RefIEXAFS)

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Conclusions	<ul> <li>A. Bonanni <i>et al.</i>, Phys. Rev. Lett. <b>101</b>, 135502 (2008)</li> <li>M. Rovezzi <i>et al.</i>, Phys. Rev. B <b>79</b>, 195209 (2009)</li> </ul>





### GaN:Fe(Mg,Si) [A. Bonanni *et al.*, Phys. Rev. B 2007]

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- Metalorganic vapour phase epitaxy (MOVPE)
- *c*-plane Al<sub>2</sub>O<sub>3</sub> (sapphire) substrates
- Precursors: TMGa (trimethilgallium), NH<sub>3</sub> (ammonia), Cp<sub>2</sub>Fe (ferrocene), Cp<sub>2</sub>Mg (bis-cyclopentadienyl-magnesium), SiH<sub>4</sub> (silane)
- In-situ monitoring: ellipsometry, XRD, laser reflectivity

### Growth procedure

- Substrate nitridation
- LT (540 °C) GaN nucl. layer
- Annealing/recrystallization
- l  $\mu$ m HT (1050 °C) GaN
- 0.5 1 μm GaN:Fe(:Mg,Si)
  - $\bullet~800-950\ ^{\circ}C$
  - 50 400 sccm<sup>a</sup> Cp<sub>2</sub>Fe

<sup>a</sup>standard cubic centimeters per minute





# Ex-situ characterizations



### Random substitutional



Low temp. Curie • paramagnetism from Fe<sup>3+</sup> (d<sup>5</sup>)



Chemical and crystallographic separation

- Enhanced ferromagnetic response
- Persisting at high temperature

Solubility limit<sup>1</sup> at 200 sccm Cp<sub>2</sub>Fe ( $\approx 0.4\%$  Fe)

<sup>1</sup> in our growth conditions



EXAFS Measurements

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### GILDA at ESRF

- Bending magnet source
- Linear polarization: out-of-plane (90°)
- Standard geometry
- High-purity 13-elements Ge detector

### LUCIA at SLS (now at SOLEIL)

- Insertion device source
- Linear polarization: in-plane (0°) and out-of-plane (90°)
- Grazing incidence geometry
- Silicon drift fluorescence detector





### Characterized samples

Overview of the parameters space

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### Low Fe content Fega as relaxed by Density Functional Theorem



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- Possible to fit up VI coordination shell with a minimum set of variables (Debye correlated model for σ<sup>2</sup>) ⇒ low local structural disorder
- Global 1% expansion to respect GaN [ $d_{Fe-N} = 1.98(1)$  Å and  $d_{Fe-Ga} = 3.19(2)$  Å]
- Experimental results in line with the Fe<sup>3+</sup><sub>Ga</sub> DFT relaxed structure (LSDA+U, 72-atoms supercell):  $d_{Fe-N} = 1.99(1)$  Å and  $d_{Fe-Ga} = 3.22(1)$  Å



## High Fe content

Crystallities appea

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•  $\approx 60(10)\%$  Fe<sub>Ga</sub>:  $d_{Fe-N} = 2.02(1)$  Å  $d_{Fe-Ga} = 3.22(4)$  Å •  $\approx 40(10)\%$   $\epsilon$ -Fe<sub>3</sub>N (Bainite):  $d_{Fe-Fe} = 2.71(2)$  Å



### Polarized measurements

#### inear dichroism sensitive to simmetry



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- Double polarization (changed at the source): in-plane (0°) and out-of-plane (90°)
- $\bullet\,$  Linear dichroism  $\Rightarrow$  incorporation in non-cubic site
- $\bullet\,$  Cubic precipitates do not contribute to the dichroic signal  $\Rightarrow\,$  additional information by EXAFS



# Solubility limit as function of Fe content

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- TMGa @ 5 sccm  $\Rightarrow$  solubility limit at  $\approx$  0.4% Fe (in our growth conds.)
- Fe < 200 sccm  $\Rightarrow$  Fe substitutional in wurtzite GaN (Fe\_Ga)
- Fe  $\geq$  200 sccm  $\Rightarrow$  Fe<sub>Ga</sub> +  $\epsilon$ -Fe<sub>3</sub>N precipitates







# Increasing growth-rate

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- $Fe_{Ga}$  for TMGa  $\ge$  8 sccm
- 100(10) % Fe<sub>Ga</sub> still for 350 sccm Cp<sub>2</sub>Fe and TMGa 15 sccm (max!)
- Solubility limit improved from  ${\approx}0.4\%$  to  ${\approx}1\%$  Fe







## Si co-doping

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- 100(10)% Fe<sub>Ga</sub>
- No additional phases are detectable
- Effect due to Fermi level shift







### Fe charge state by XANES Study of pre-edge peaks $(1s \rightarrow 3d \text{ transitions})$

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(Gá,Fe)N (Gá,Fe



• I @ 7113.9(1) eV 
$$\Rightarrow$$
 Fe<sup>3+</sup>

• I @ 7113.9(1)  $eV \Rightarrow Fe^{3+}$ • II @ 7112.8(1)  $eV \Rightarrow Fe^{2+}$ 



By affecting the Fe charge state, the Coulomb repulsion overcompensate the lowering of the free energy due to the nearest-neighbour bonding [Dietl, Nature Mat. (2006)]



# Mg co-doping

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2 3 4 5 6 R (Å) – [without phase correction]

- No charge state change (Fe<sup>3+</sup>)
- Additional d<sub>Fe-Fe</sub> = 2.57(1) Å increasing in amplitude
- Closer to γ-Fe (fcc) or ζ-Fe<sub>2</sub>N (orthorombic) than α-Fe (bcc)
- Precipitates visible by SXRD





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### In collaboration with



### Part of the present work published in

### M. Rovezzi et al., Appl. Phys. Lett. 92, 242510 (2008)



# $Ge_{1-x}Mn_x$ self-organized Nano-Columns

A. Jamet et al., Nat. Mater. (2006) & T. Devillers and al. Phys. Rev. B (2007)

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### Sample growth

- LT-MBE, co-dep. of Ge and Mn
- Ge(001) substrate + Ge buffer
- Growth temp.: 80 °C 200 °C
- Mn concentration: 0.1% 20%(Mn solubility in Ge is very low,  $\approx 10^{-5}\%$ )



### 2D spinodal decomposition

- High-T<sub>C</sub> self-organized nanocolumns (> 400 K)
- Diameter 3 nm, volume fraction 16%





Nano-columns phase diagram

TEM and magnetic (SQUID) characterization

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80–120 °C

# 50 nm Ge substrate



- Fully strained low-T<sub>C</sub> NCs
- Narrow size distribution
- Superparamagnetism

120-145 °C

- Columns diameter increase
- Ferromagnetism
- High-T<sub>C</sub> NCs around 130 °C
- Large and amorphous columns

145-180 °C

 Major contribution from Ge<sub>3</sub>Mn<sub>5</sub>



180-200 °C

Ge<sub>3</sub>Mn<sub>5</sub> clusters



### Structural characterization

A challenging system



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### Data analysis

- Comparison with reference samples: Ge<sub>3</sub>Mn<sub>5</sub> and GeMn(0.1%)
- Fits using multiple data sets (to compensate the reduced information content in EXAFS)



• Assisted by *ab initio* DFT calculations (in the limit of LSDA approx.)



### Model sample: Ge<sub>3</sub>Mn<sub>5</sub> Thin film (~10 nm) grown on Ge(111) at 350 °C

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Distance, R (Å) – [without phase correction]

	N	In <sub>1</sub>	N	1n <sub>2</sub>	Avera	ge
	coord.	dist. (Å)	coord.	dist. (Å)	coord.	dist. (Å)
d2	2 Mn <sub>1</sub> 6 Ge	2.526 2.538	2 Ge	2.488	4.4 Ge&Mn	2.507
d <sub>3</sub>			1 Ge 2 Ge	2.610 2.768	1.8 Ge	2.715
d <sub>4</sub>	6 Mn <sub>2</sub>	3.065	2 Mn <sub>2</sub> 4 Mn <sub>2</sub> 4 Mn <sub>1</sub>	2.983 3.058 3.065	8.4 Mn	3.053
			11 (0			



Mn1 (40% of the sites)



Mn<sub>2</sub> (60% of the sites)

Crystallographic (Ge<sub>3</sub>Mn<sub>5</sub>) distances



# Model sample: Mn "diluted" in Ge

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Site				Dista	ance (Å) /	Coordi	nation						
	d <sub>1</sub>		d <sub>2</sub>		d <sub>3</sub>	d <sub>3</sub>		d5		d <sub>6</sub>			
Mns	-	-	2.45	4	-	-	-	-	4.00	12			
MnT	-	-	2.45	4	2.83	6	-	-	-	-			
Mn <sub>H</sub>	2.35	6	-	-	-	-	3.67	8	-	-			

Crystallographic (Ge diamond) distances

Elementary defects in Ge



Substitutional, MnS



Tetrahedral interstitial, Mn<sub>S</sub>



Hexagonal interstitial,  $Mn_H$ 



### GeMn nanocolumns





Sample	Distance (Å) / Coordination							
	d	2	6	4 <sub>3</sub>	C	4	d	5
T <sub>G</sub> = 125 °C:								
GeMn(0.1%)	2.47(1)	4.2(5) <sup>a</sup>	-	-	-	-	3.57(2)	1.2(4) <sup>a</sup>
GeMn(1%)	2.48(1)	4.0(5) <sup>a</sup>	-	-	-	-	3.60(4)	0.8(5) <sup>a</sup>
GeMn(6%)	2.49(1)	4.0(5) <sup>a</sup>	2.82(4)	0.8(4) <sup>C</sup>	3.09(4)	0.8(4) <sup>C</sup>	-	-
GeMn(20%)	2.49(1)	4.0(5) <sup>a</sup>	2.82(2)	1.6(2) <sup>b</sup>	3.10(2)	1.4(3) <sup>b</sup>	-	-
Mn 6 %:								
GeMn(120°C)	2.48(1)	4.2(5) <sup>a</sup>	-	-	-	-	3.57(4)	0.7(3) <sup>a</sup>
GeMn(130°C)	2.49(1)	4.0(5) <sup>a</sup>	2.86(5)	1.2(4) <sup>C</sup>	3.10(5)	1.3(4) <sup>C</sup>	-	-
GeMn(135°C)	2.49(1)	4.0(5) <sup>a</sup>	2.80(2)	1.0(2) <sup>C</sup>	3.07(2)	1.2(2) <sup>b</sup>	-	-
GeMn(140°C)	2.49(1)	4.0(5) <sup>a</sup>	2.80(2)	1.4(2) <sup>C</sup>	3.06(2)	1.1(3) <sup>b</sup>	-	-
GeMn(150°C)	2.49(1)	4.0(5) <sup>a</sup>	2.81(2)	3.7(7) <sup>b</sup>	3.01(2)	2.2(4) <sup>b</sup>	-	-
Reference sample	e on Ge(111):							
Ge <sub>3</sub> Mn <sub>5</sub>	2.52(1)	5.0(5) <sup>d</sup>	2.70(5)	1.2(4) <sup>a</sup>	3.04(5)	8.4(5) <sup>b</sup>	-	-
2	h (	d						

k (Å<sup>-1</sup>)

Backscatterer: <sup>a</sup> Ge; <sup>b</sup> Mn; <sup>c</sup> Ge or Mn; <sup>a</sup> Ge and Mn.



### GeMn nanocolumns

Proposed atomic models

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### Building block



- Only the Ge-3Mn<sub>2</sub> tetrahedron fits with experimental results
- NCs are precursors of Ge<sub>3</sub>Mn<sub>5</sub> ⇒ increase of d<sub>4</sub> coordination number with temp. and conc.

### Linking block

[Ahlers, PhD Thesis (2009)]

- Pure ball-and-stick model (not relaxed!) ⇒ links Ge<sub>3</sub>Mn<sub>5</sub> to Ge(111) with native defects
- $\bullet~$  3  $Mn_2~as~Mn_{\rm H}$  on Ge(111) + 2  $Mn_1$   $\perp~as~Mn_T$  and  $Mn_S$
- Compatible with present results





### Mn in GaAs

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### Growth

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- Riber 32 R&D chamber, sources: standard effusion cells
- Growth procedure (monitored by RHEED):
  - GaAs buffer layer on semi-insulating (001) GaAs substrate at 590 °C + cooled to 200–300 °C
  - IT-GaAs (0–100 nm)
  - Ga<sub>1-x</sub>Mn<sub>x</sub>As at 250 °C (x=6%, 133 nm)
  - LT-GaAs capping layer (0–6 nm)
- Annealing: at  $\approx$ 285 °C for 70 min in  $N_2$

### Curie temperature

From  ${\approx}60$  K in as deposited samples to  ${\approx}110$  K with annealing  ${\Rightarrow}$  surface migration of  $Mn_{\textit{interstitial}}$  defects and neutralization with oxide

[Kirby et al., Phys. Rev. B 2006]





100

### RefIEXAFS measurements

1400





- Mn K-edge fluorescence in grazing-incidence mode
- Working around critical angle  $\theta_c \approx 0.35^{\circ}$ 
  - Total reflection (0.80θ<sub>c</sub>): probing the surface (< 10 nm)
- High incidence (1.2θ<sub>c</sub>): probing the whole doped layer
- Reflectivity monitored during the energy scan



# Mn substitutional (Mn<sub>Ga</sub>)

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- First shell expansion: Mn-As @ 2.50(1) Å, typical 2% exp.
- Local structure well fitted up to VI coordination shell
- Model with minimum set of variables and Debye correlated model for  $\sigma^{\rm 2}$





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- Model: ΞMn<sub>I</sub>+(1-Ξ)Mn<sub>Ga</sub>
- Fingerprint: 6 Mn-Ga at 2.827 Å (crystallographic)
- First shell  $\approx$ 2% exp.,  $\approx$ 1% upper distances
- 10(5)%  $< \Xi <$  20(5)% in selected samples ( $\chi^2$ -tested)
- Oxide contribution by 6 Mn-O at 2.222(1) Å (cryst.)
- MnO detectable only in RefleEXAFS (< 6 nm GaAs CL)



# Standard versus grazing-incidence geometry

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Standard geometry

RefIEXAFS at HI





- The same parameters for the extraction and the fits
- $\bullet~$  Only  $Mn_{Ga}$  is detected in the first case while in the second also  $Mn_{I}$  and MnO are visible
- The surface study is crucial in understanding Mn<sub>I</sub> mobility and interaction with the thin surface oxide layer



### Surface systematic study

As function of annealing and GaAs capping layer



#### Results





### [Olejnik et al., Phys. Rev. B (2008)]

#### Introduction

Spintronie XAFS

#### Fe in GaN Incorporations

Series Co-doping

Mn in Ge Models

Mn in GaAs Models Surface study

Conclusions



### In situ post-growth etch-anneal procedure

(E)XAFS

### Etching

- 30s in 35% HCl
- rinsing in water + blow dry by N<sub>2</sub> gas
- transfer to vacuum chamber

### (E)XAFS

### Annealing

- 20 min at 200 °C on hotplate under N<sub>2</sub> gas flow
- rapid quench to room temperature under N<sub>2</sub> gas flow
- tranfer to vacuum chamber

### (E)XAFS





# Etching/Annealing



		N	ΛnΟ	Mn <sub>I</sub>		Mn <sub>Ga</sub>			
	$\phi_W$	Θ	RO	Ξ	R <sub>Ga</sub>	R <sub>As</sub>	$\sigma^2_{As}$	R <sub>Ga</sub>	$\sigma_{Ga}^2$
		(%)	(Å)	(%)	(Å)	(Å)	(Å <sup>2</sup> )	(Å)	(Å <sup>2</sup> )
		±5	$\pm 0.02$	±7	$\pm 0.06$	$\pm 0.01$	$\pm 0.002$	$\pm 0.05$	$\pm 0.005$
E+	HI	-	-	-	-	2.50	0.007	4.06	0.017
LI.	TR	12	2.14	19	2.94	2.50	0.007	4.02	0.014
Et & An	HI	7	2.14	-	-	2.51	0.006	4.03	0.025
LL.GAIL	TR	12	2.15	14	2.82	2.49	0.004	4.04	0.018





Summary

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- Fe in GaN Incorporations Series
- Mn in Ge Models
- Mn in GaAs Models Surface study Etch-anneal

Conclusions



- Fe incorporation in GaN can be efficiently controlled by Fe flow, growth rate, and co-doping with Si
- EXAFS well identify the substitutional phase (Fe<sub>Ga</sub>) and the presence of precipitates (ε-Fe<sub>3</sub>N)
- The aggregation of Fe cations can be minimized by increasing the growth rate and by co-doping with Si, shifting the solubility limit towards higher Fe content at given growth conditions
- Detailed informations about Fe charge state are obtained from XANES: from Fe<sup>3+</sup> (isoelectronic impurity) to partial reduction Fe<sup>2+</sup> upon Si addition (Fermi level engineering)
- Co-doping with Mg do not introduce charge shift but promotes precipitation (difficult to distinguish by XAFS)
- Exploiting the complementarity of XAFS with XRD and TEM permits a fine structural characterization of this system at the nano-scale



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- The high local disorder reduces the information content in the EXAFS spectra (like Mn in Si [A. Wolska *et al.*, Phys. Rev. B 2007])
- Mn-rich NCs present a complex local structure that cannot be described only with a substitutional model
- Additional interatomic distances have to be considered in the EXAFS analysis which are in good qualitative and quantitative agreement with the structure of one of the Ge-3Mn building block tetrahedron found in Ge<sub>3</sub>Mn<sub>5</sub> crystal
- Samples grown at low temperature or low Mn content present additional hexagonal interstitial-like defects (≈10 %)



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Conclusions



- LT-MBE permits the fabrication of a good DMS system with Mn main incorporation as Mn<sub>Ga</sub> in a crystalline environment
- Enrichment of Mn<sub>I</sub> at the surface: detected in grazing-incidence and not in standard geometry ⇒ GIXAFS/RefIEXAFS is powerful local probe to study surface phenomena
- The effects of post-growth annealing on Mn<sub>I</sub> surface migration are investigated but it is not possible to link the observed efficacy of this method to the interaction with the surface oxide
- The presence of the oxide phase reduces the sensitivity to Mn<sub>I</sub>, even with the use of a GaAs capping layer of different thickness
- The etch-annealing process is fruitful in removing  $Mn_I \Rightarrow$  first direct evidence of the neutralization process induced by this method



### General conclusions

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- Mn in GaAs Models Surface study Etch-anneal

Conclusions



- The present work has permitted to find out the potentialities and limits of XAFS spectroscopy in the study of semiconductor spintronics
  - A wide spectrum of the most promising materials in this field has been examinated (keeping apart semiconductor oxides while Mn-doped II-VI class investigated in the early times)
  - Experimental work: implementation of a new sample holder for measurements in grazing-incidence geometry and a new data analysis method for RefIEXAFS measurements
  - XAFS combined with complementary advanced characterization tools helps in the fine tuning of the deposition parameters and post-growth treatments



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- Fermi level engineering to increase the solubility limit (demostrated here for GaFeN) on GaMnAs [Cho et al., Appl. Phys. Lett. (2008)] and GeMn [Chen et al., Phys. Rev. B (2009)] via *n*-type counter-doping
- Fine tune the temperature parameter and adopt Fe doping in  $\delta\text{-fashion}$  to obtain Fe-rich nanocolumns in GaN
- High-level doping with shallow acceptors to reach the metal-insulator transition and have high-T<sub>C</sub> ferromagnetism (moving from weak to strong coupling regime) [Dietl, Phys. Rev. B (2008)]



# Acknowledgements

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- Fe:GaN Alberta Bonanni<sup>2</sup>, Andrea Navarro-Quezada<sup>2</sup>, Tian Li<sup>2</sup>, Bogdan Faina<sup>2</sup>, Tomasz Dietl<sup>3</sup>, Piotr Bogusławski<sup>3</sup>, Paweł Jakubas<sup>3</sup>, Aldo Amore Bonapasta<sup>4</sup> and Francesco Filippone<sup>4</sup>
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### **Bibliographic databases**

My personal collection ( $\approx$ 600 refs.):

http://www.mendeley.com/profiles/mauro-rovezzi Ferromagnetic Semiconductor Spintronics Web Project:

http://unix12.fzu.cz/ms/





## Mn in III-V nanowires

Soutenance de thèse

M. Rovezzi

Mn in NWs

Local structure

### In collaboration with







### Growth of GaAs and InAs NWs

F. Martelli *et al.*, Nano Lett. (2006

Soutenance de thèse

M. Rovezzi

Mn in NWs

- Solid-state molecular beam epitaxy (VLS growth)
- Catalyzed by Mn (5 ML, 1 nm) and Au (10 ML, 2 nm) [+doped with Mn]
- Growth temperature: 535 °C – 620 °C
- Different substrates: GaAs and SiO<sub>2</sub>

### Electron microscopy



SEM images: (a) Mn-cat GaAs on SiO<sub>2</sub>; (b) Mn-cat InAs on SiO<sub>2</sub>; (c) Mn-cat GaAs on GaAs; (d) Au-cat GaAs on GaAs(111)





Soutenance de thèse

M. Rovezzi

Mn in NWs

- Mn K-edge in fluorescence mode @ GILDA [standard geometry, low temp.: 10 K]
- All samples etched *in-situ* and transferred to vacuum chamber to avoid oxide formation
- Systematic study varying deposition parameters

### Characterized samples

Sample	Wire	Cat.	Temp. (°C)	Time (min)
E650	GaAs	Mn	540	30
E651	GaAs	Mn	580	30
E672	GaAs	Mn	610	30
E652	GaAs	Mn	620	30
E656	GaAs	Au	540	30
E697	GaAs	Au	580	30
E683	InAs	Mn	390	60





### **Mn-catalyzed**

Soutenance de thèse

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Mn in NWs Local structure GaAs NWs



- High local disorder
- Mn<sub>Ga</sub> but Mn-As at 2.58 Å ⇒ MnAs clusters
- Mn-Mn at 2.15 Å (no Mn-O!)

### InAs NWs



- Low local disorder
- No Mn substitutional in wz-InAs
- Mn in hexagonal MnAs Mn-Mn at 2.85 Å and 3.72 Å





### Au-catalyzed + Mn-doped

Soutenance de thèse

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Mn in NWs



- $Mn_{Ga}$  with Mn-As at 2.58 Å
- + cubic MnAu [Mn-Au at 2.79 Å]
- Fingerprint: Mn-Au-Mn collinear scattering path





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- M. Rovezzi
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- Mn-As bond distance of 2.56–2.58 Å, longer than the expected value for a substitutional site and probably due to the occupation of defect sites ⇒ seeds for the formation of hexagonal MnAs precipitates
- Hexagonal MnAs clearly forms in Mn-cat. InAs NWs (well ordered local structure)
- Mn-Mn dimers at 2.15 Å found in Mn-cat. GaAs NWs (also reported by other groups: Mn-doped InAs at 2.19 Å, Mn-doped Ge at 2.04 Å)
- Mn in Au-catalyzed NWs forms an intermetallic alloy with Au resulting in a well ordered cubic MnAu

